

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2891**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

please
enter
/CME/
7-9-2008

In re the Application of
Hideharu ITATANI et al.
Application No.: 10/521,248
Filed: April 11, 2005
For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND SUBSTRATE
PROCESSING APPARATUS

Group Art Unit: 2891
Examiner: C. EVERHART
Docket No.: 122430

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the March 24, 2008 and April 1, 2008 Office Actions, please consider the
following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.